

In re Patent Application of

MANABE et al.

Confirmation No. 4113

Application No.: 10/052,347

Group Art Unit: 2812

Filed: January 23, 2002

Examiner: Not Yet Assigned

FOR: METHOD FOR MANUFACTURING A GALLIUM NITRIDE GROUP

MAY 1 5 2002

COMPOUND SEMICONDUCTOR

May 15, 2002

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents Washington, DC 20231

Sir:

Enclosed are a Form PTO-1449 and copies of references cited in two Japanese Office Actions, dated February 19, 2002 and March 12, 2002, respectively, and other documents for the Examiner's consideration. Each Japanese reference has an English abstract for the Examiner's convenience.

This Information Disclosure Statement is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Consideration of the foregoing and enclosures plus the return of a copy of the herewith Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 along with an early Action on the merits of this application are earnestly solicited.

Respectfully submitted,

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